

**Search Notes**

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10/549,376

Examiner

Louis K. Huynh

Applicant(s)/Patent under  
Reexamination

FENN, DAVID

Art Unit

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**SEARCHED**

Class	Subclass	Date	Examiner
53	329.3 372.6 374.8 374.9 375.6	7/11/2007	LH
53	477 485 486	7/11/2007	LH
53	487 289 290	7/11/2007	LH

**INTERFERENCE SEARCHED**

Class	Subclass	Date	Examiner

**SEARCH NOTES  
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR